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Wan et al.

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(54) **APPARATUS AND METHOD FOR POLISHING AN EDGE OF AN ARTICLE USING MAGNETORHEOLOGICAL (MR) FLUID**

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B24B 1/00 (2006.01)
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CPC ***B24B 1/005*** (2013.01); ***B24B 9/102*** (2013.01); ***B24B 35/00*** (2013.01)

(58) **Field of Classification Search**
CPC B24B 9/00; B24B 9/14; B24B 9/148; B24B 13/005; B24B 9/146; B24B 49/02
USPC 451/36, 37, 43, 296, 446, 113, 106, 74
See application file for complete search history.

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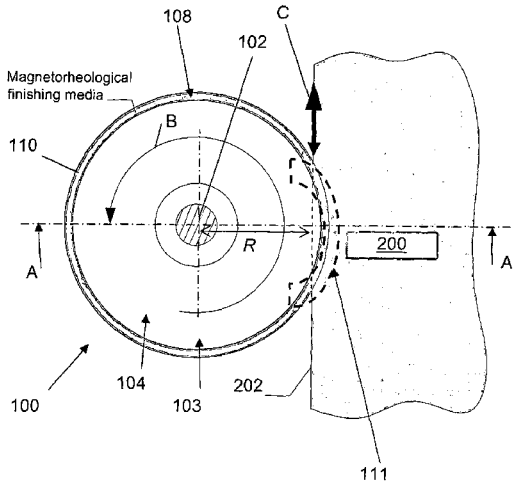
(57) **ABSTRACT**

Disclosed is a method and apparatus for polishing an edge of an article involving providing at least one carrier including: first and second opposing surfaces defining a groove, the first and second opposing surfaces being spaced apart in a first direction to receive the edge; and magnetic field generator configured to provide a magnetic field in the groove to stiffen magnetorheological (MR) fluid disposed in the groove to provide at least one polishing zone; receiving the edge in the polishing zone; and driving relative motion between the at least one carrier and the edge in a second direction substantially transverse to the first direction.

19 Claims, 10 Drawing Sheets



(51) **Int. Cl.**
B24B 35/00 (2006.01)
B24B 9/10 (2006.01)

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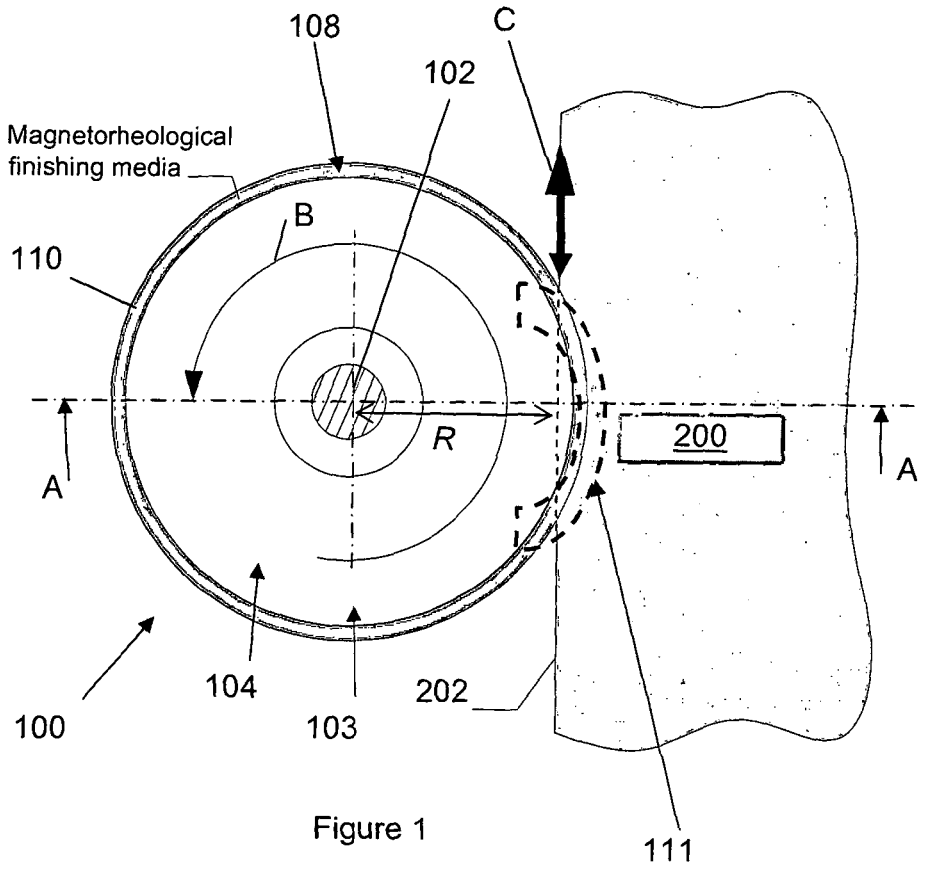

Figure 1

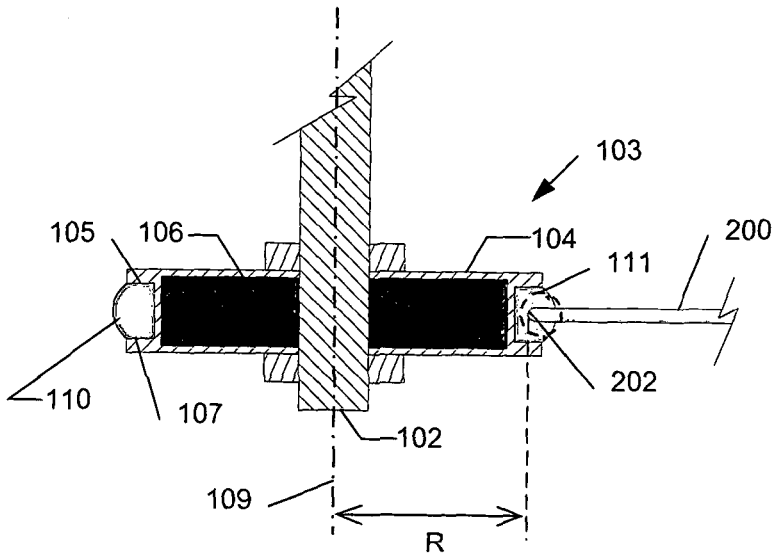

Figure 2

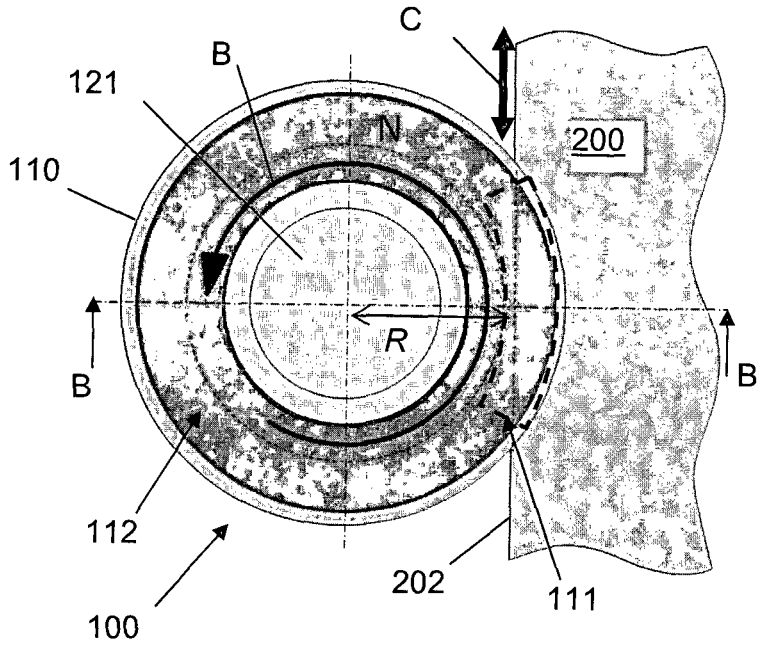

Figure 3a

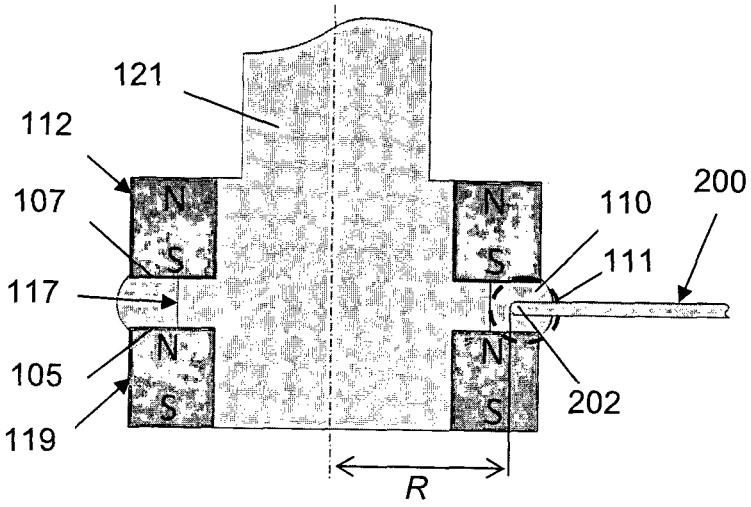

Figure 3b

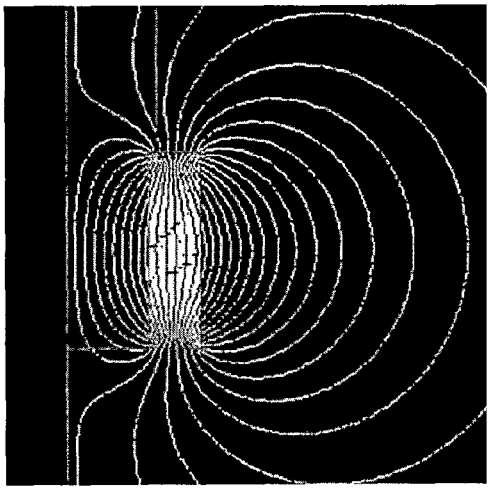

Figure 4a

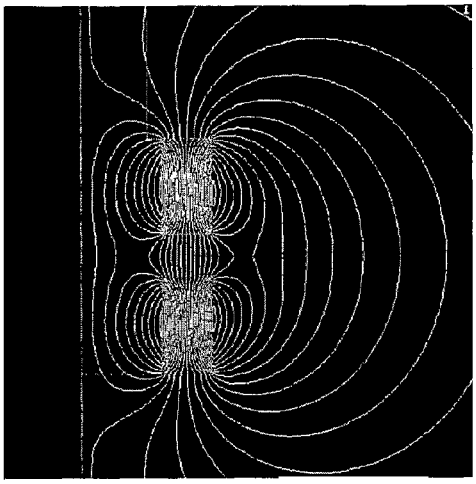

Figure 4b

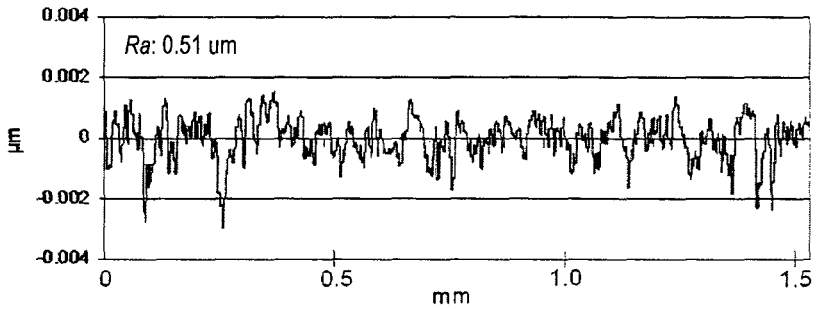

Figure 5(a)(i) Unpolished surface (Ground surface)

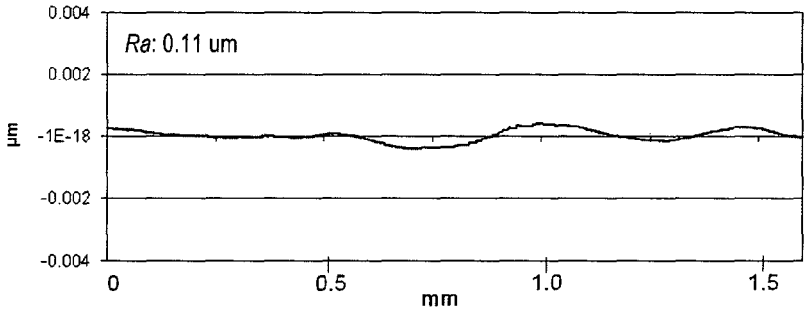

Figure 5(a)(ii) Surface polished by a single magnet

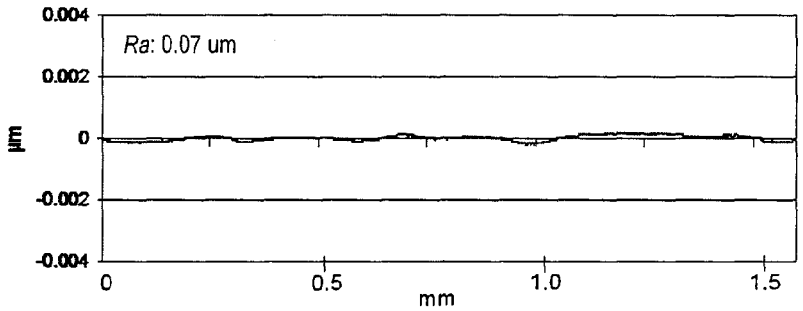

Figure 5(a)(iii) Surface polished by a pair magnets

Figure 5a: Comparison of unpolished and polished surface (surface roughness profile)

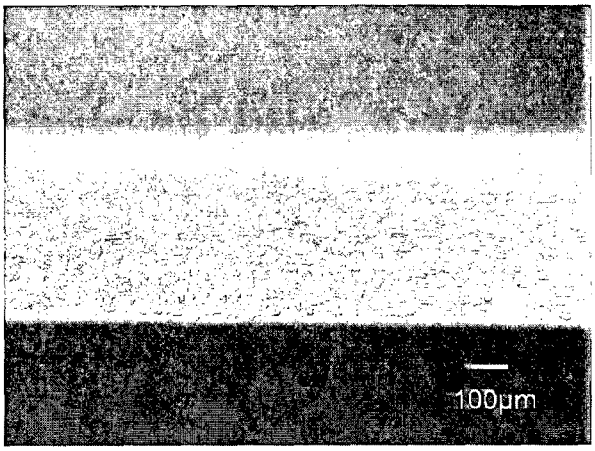

Figure 5(b)(i) Unpolished surface (Ground surface)

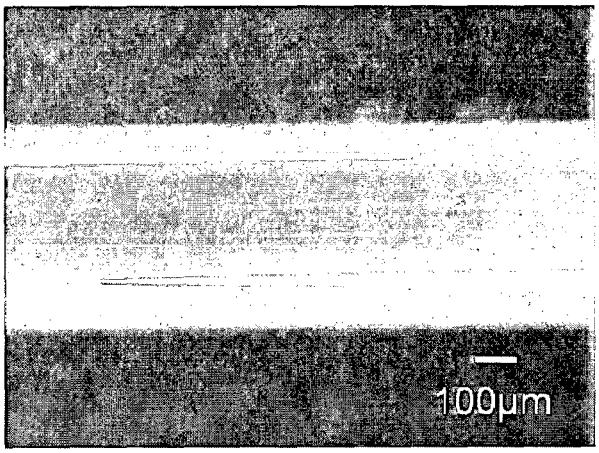

Figure 5(b)(ii) Surface polished by a single magnet

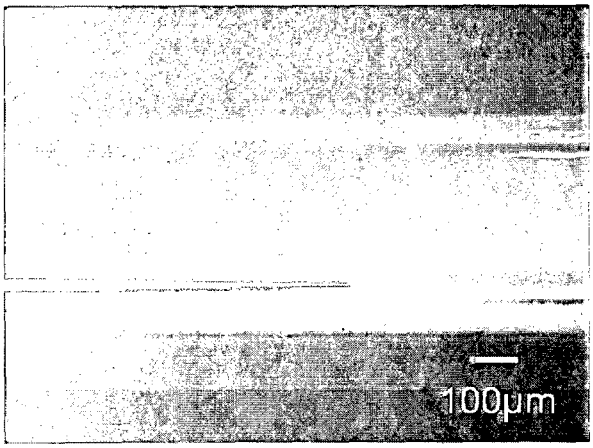

Figure 5(b)(iii) Surface polished by a pair magnets

Figure 5b: Comparison of unpolished and polished surface (photo of surface)

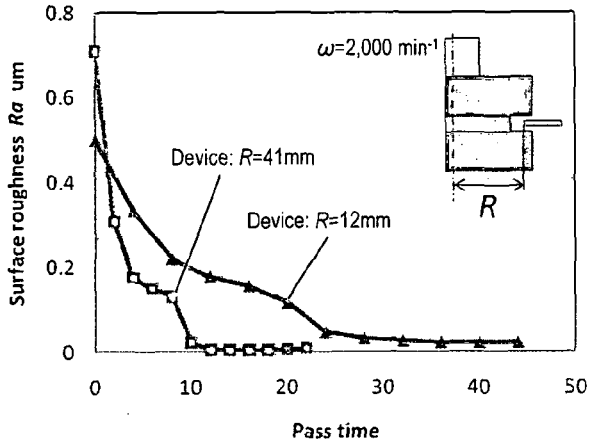

Figure 6: Comparison in variation of surface roughness with pass time polished by different *R* device

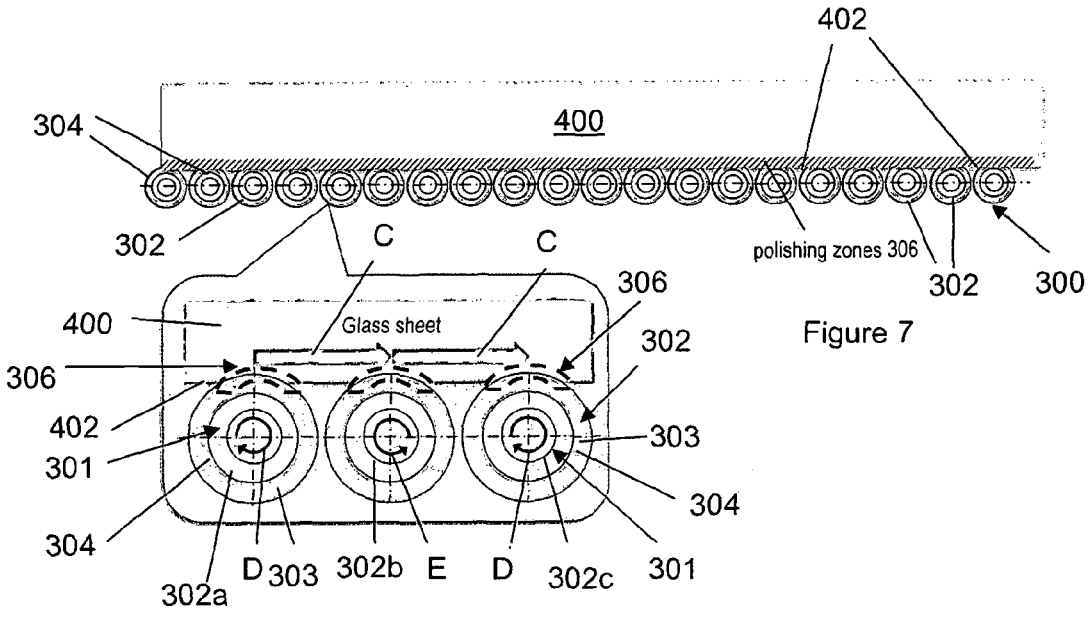

Figure 7

Figure 8

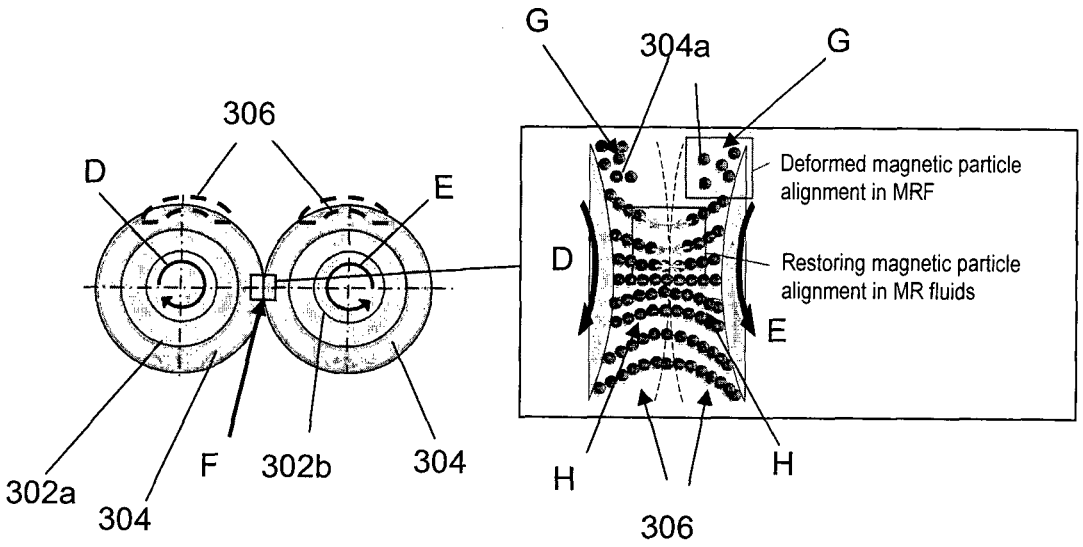

Figure 9

Figure 10

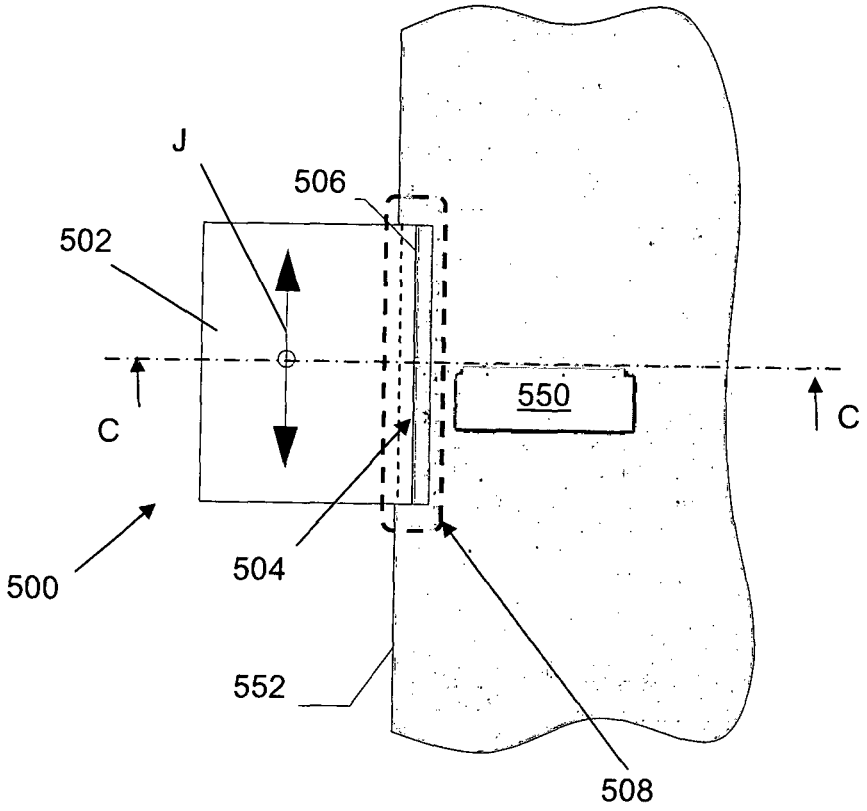

Figure 11

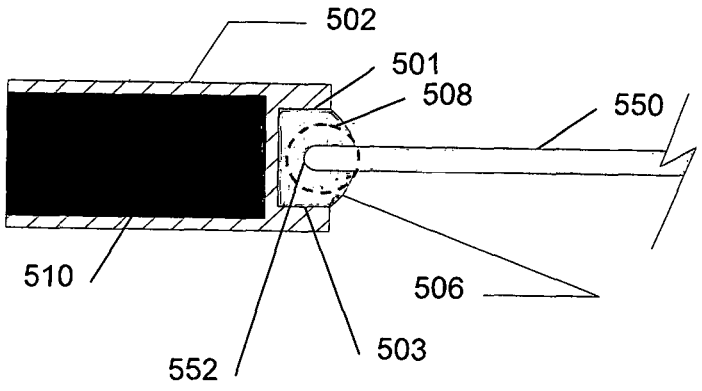

Figure 12

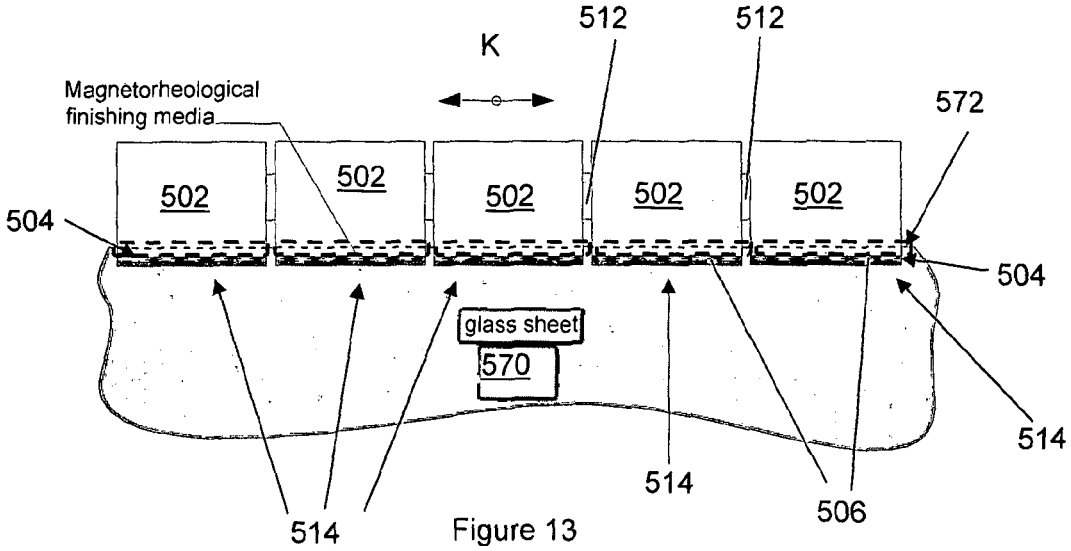

Figure 13

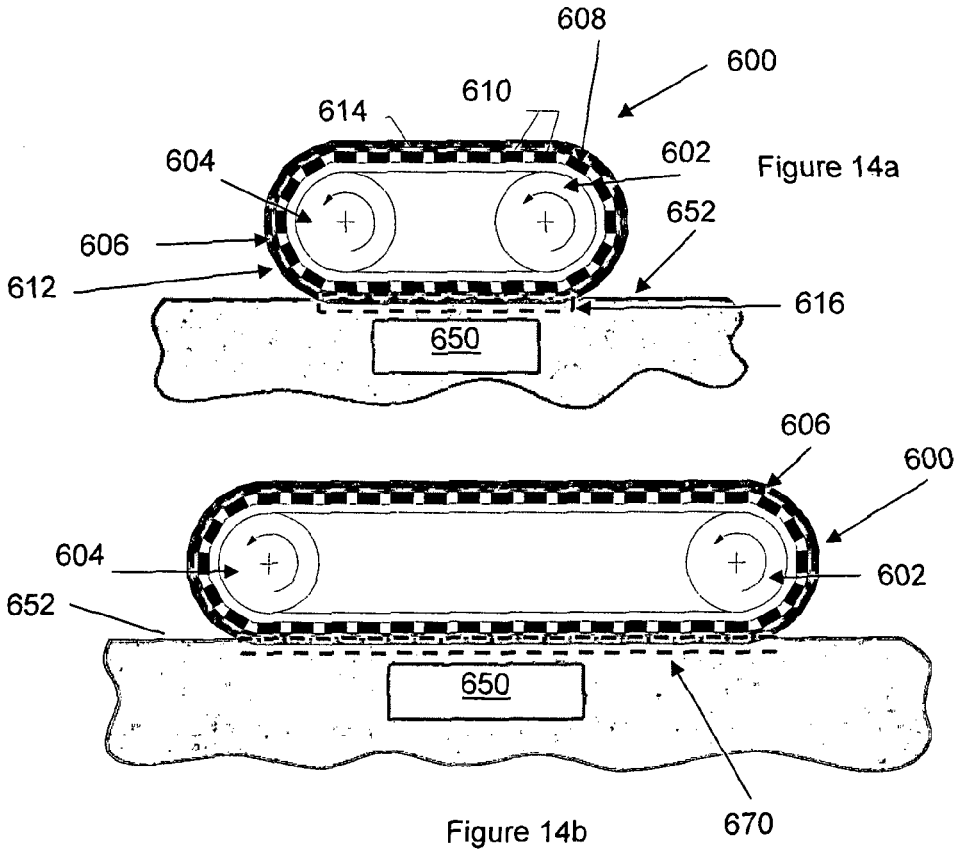

Figure 14a

Figure 14b

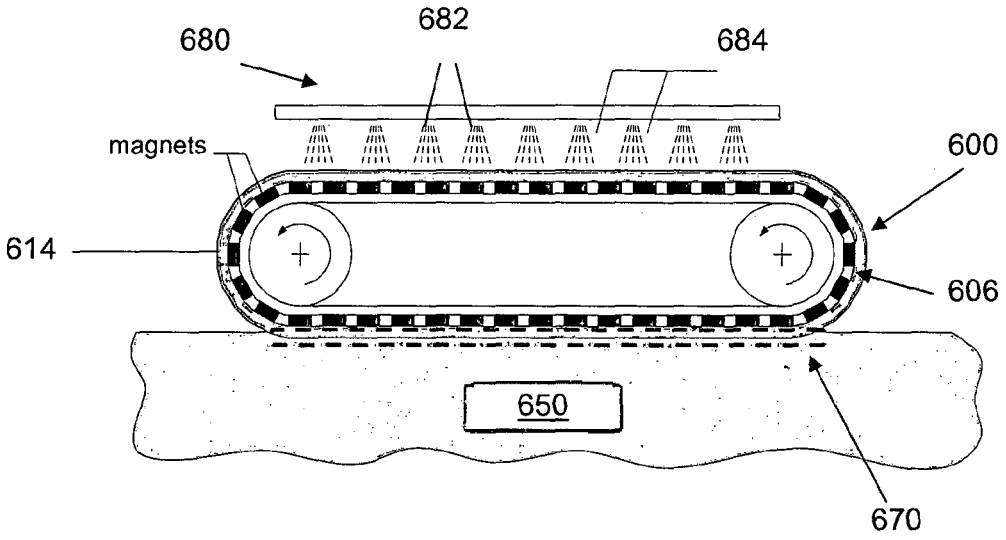

Figure 15

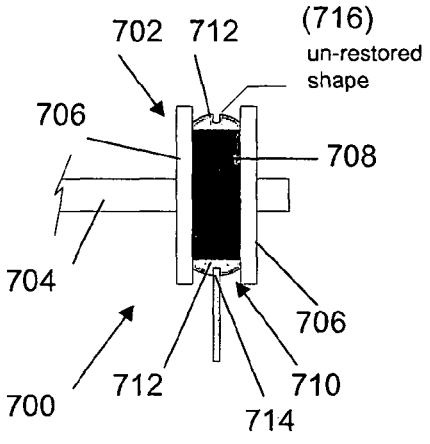

Figure 16

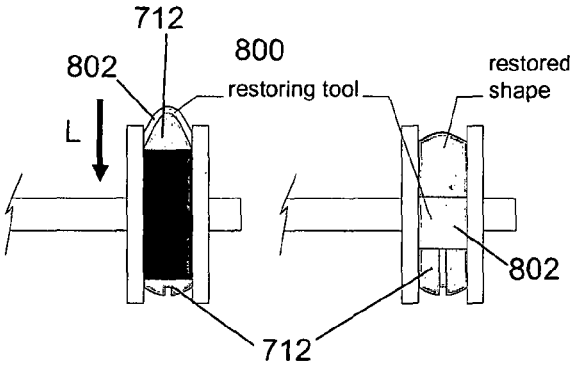

Figure 17a Figure 17b

APPARATUS AND METHOD FOR POLISHING AN EDGE OF AN ARTICLE USING MAGNETORHEOLOGICAL (MR) FLUID

CROSS-REFERENCE TO RELATED APPLICATIONS

This patent application is a U.S. National Phase Application under 35 U.S.C. §371 of International Application No. PCT/SG2011/000405, filed Nov. 15, 2011, entitled APPARATUS AND METHOD FOR POLISHING AN EDGE OF AN ARTICLE USING MAGNETORHEOLOGICAL (MR) FLUID, which claims priority to Singapore Patent Application No. 201008438-2, filed Nov. 15, 2010.

FIELD

This invention relates to an apparatus and method for polishing an edge of an article using magnetorheological fluid, more particularly but not exclusively, for polishing the edges of large glass panels.

BACKGROUND

It is known to use magnetorheological finishing (MRF) uses magnetorheological (MR) fluid to polish or remove materials from surfaces of optical lens. The MR fluids include suspensions of ferro-magnetic particles carried by a carrier fluid. Under influence of a magnetic field, the ferro-magnetic particles are magnetized by the magnetic field and viscosity of the MR fluid changes almost instantaneously from a liquid state to a semi-solid state which is still sufficiently pliant to conform to a surface of a workpiece being polished. However, for certain applications, such as removal of sub-surface damage including sub-surface micro-crack, current MRF techniques do not yield sufficiently useful material removal rates for required production yields. Commercially available glass polishing disks are also not suitable for removing sub-surface micro-cracks.

There is therefore a need to provide an apparatus and method for polishing an edge of an article using magnetorheological fluid to address at least one of the disadvantages of the prior art and/or to provide the public with a useful choice.

SUMMARY

In accordance with a first aspect, there is provided an apparatus for polishing an edge of an article using a magnetorheological (MR) fluid, the apparatus including at least one carrier including first and second opposing surfaces defining a groove, the first and second opposing surfaces being spaced apart along a first direction to receive the edge; and a magnetic field generator configured to provide a magnetic field in the groove, wherein in operation the MR fluid is disposed in the groove and stiffens in response to the magnetic field to provide at least one polishing zone; and a driver configured to provide relative motion between the at least one carrier and the edge of the article in a second direction substantially transverse to the first direction for polishing the edge of the article in the at least one polishing zone.

The magnetic field generator may further include first and second permanent magnets providing the first and second opposing surfaces respectively. The magnetic field generator can be configured to provide the magnetic field throughout the groove such that the MR fluid is stiffened throughout the groove.

The groove can be configured to retain substantially all of the MR fluid disposed therein. The groove can be annular, the groove being characterised by an axis of rotational symmetry parallel to the first direction. The groove may extend substantially parallel to the second direction.

The apparatus can be configured such that the relative motion further includes a reciprocating motion. The relative motion may include rotational motion of the at least one carrier.

The apparatus may include a plurality of the carriers aligned substantially parallel to the second direction to simultaneously provide at least one polishing zone. The apparatus may be configured such that each one of the at least one carrier is rotatable about an axis parallel to the first direction. Immediately adjacent ones of the carriers are rotatable in different directions.

Optionally, the apparatus may include a restoring tool configured to shape the MR fluid.

The at least one carrier may further include a conveyor configured to provide the first and second opposing surfaces, the conveyor being operable by the driver. The magnetic generator may include a plurality of magnets arranged equidistantly along the conveyor. The apparatus can further include a moisturizing device configured to moisturize the MR fluid.

In another aspect, there is provided a method for polishing an edge of an article, the method comprising: providing at least one carrier including: first and second opposing surfaces defining a groove, the first and second opposing surfaces being spaced apart in a first direction to receive the edge; and a magnetic field generator configured to provide a magnetic field in the groove to stiffen magnetorheological (MR) fluid disposed in the groove to provide at least one polishing zone; receiving the edge in the polishing zone; and driving relative motion between the at least one carrier and the edge in a second direction substantially transverse to the first direction.

The method may include stiffening the MR fluid throughout the groove. The method may further include retaining substantially all of the MR fluid disposed in the groove. The method may include simultaneously receiving different parts of the edge in the groove. The method may further include rotating immediately adjacent ones of the carriers in different directions.

An advantage of the described embodiment is that with the plurality of polishing zones to polish different portions of the linear surface simultaneously, polishing time may be reduced and material removal rate may also be increased.

With an elongate polishing zone, a much quicker polishing time of the linear surface may be achieved.

With the pair of magnetic field generators, the generators generate respective magnetic fields which compliment each other to generate a combined magnetic field of greater intensity. In this way, a much quicker grinding or polishing is achieved.

BRIEF DESCRIPTION OF THE DRAWINGS

Examples of the invention will now be described with reference to the accompanying drawings, in which:

FIG. **1** is a schematic diagram of a top view of an apparatus according to one embodiment;

FIG. **2** is a cross-sectional view of the apparatus of FIG. **1** in the direction AA;

FIG. **3***a* is a schematic diagram of a top view of an apparatus according to another embodiment;

FIG. **3***b* is a cross-sectional view of the apparatus of FIG. **3***a* in the direction BB, which is a first embodiment of the invention having a pair of permanent magnets;

FIG. **4***a* is a simulation result of magnetic flux distribution of a single magnet similar to what would be generated by the apparatus of FIG. **1**;

FIG. **4***b* is a simulation result of magnetic flux distribution of a pair of magnets similar to what would be generated by the apparatus of FIG. **3**;

FIGS. **5***a*(*i*) to (*iii*) and **5***b*(*i*) to (*iii*) show a series of surface roughness profiles and magnified photographs respectively to compare between unpolished and polished surfaces using the arrangements of FIGS. **1** and **3**;

FIG. **6** is a graph illustrating effects of different radius values of cylindrical housing of FIG. **1** on surface roughness of a surface to be polished;

FIG. **7** shows the apparatus according to one embodiment having a plurality of carriers arranged in an end-to-end relationship with each other to polish a glass edge;

FIG. **8** is an enlarged view of a portion of FIG. **7** which shows three of the carriers and their respective polishing zones;

FIG. **9** shows two of the carriers of FIG. **8** which are immediately adjacent to each other and illustrating that they are rotating in different directions;

FIG. **10** is a magnified view of region F of FIG. **9** to illustrate effects of rotating the two movable carriers in different directions;

FIG. **11** illustrates another embodiment of the apparatus for increasing the contact velocity of the apparatus;

FIG. **12** is a cross-section view of FIG. **11** in the direction CC;

FIG. **13** illustrates another embodiment which employs a plurality of carriers of FIG. **11**;

FIG. **14***a* shows the apparatus according to one embodiment of the apparatus;

FIG. **14***b* shows the apparatus of FIG. **14***a* adapted to provide a longer elongate polishing zone;

FIG. **15** shows the apparatus of FIG. **14***b* having a moisturizing device for moisturizing the MR fluid;

FIG. **16** shows the apparatus for polishing a glass edge using MR fluid to illustrate effects of the polishing on the MR fluid; and

FIGS. **17***a* and **17***b* illustrate a restoring tool for restoring the shape of the MR fluid of FIG. **16**.

DETAILED DESCRIPTION OF PREFERRED EMBODIMENTS

To appreciate advantages of the embodiments, it would be useful to begin with an explanation of various parameters which may affect material removal rate of a magnetorheological finishing (MRF) process.

It has been found that tribologically, the MRF process is a combination of two and three body abrasive wear. Hence, the following process equations discussed are applicable to the MRF process:

$$R_a = (R_i - R_\infty)\cdot e^{-\frac{k_T p_a v}{H}} + R_\infty \quad (1)$$

$$h = a\cdot(R_i - R_\infty)\cdot\left(1 - e^{-\frac{k_T p_a v}{H}t}\right) + \frac{k_S p_a v}{H}t \quad (2)$$

where

R_a is surface roughness achieved in a polishing time, t from an initial surface roughness, R_i of a surface to be polished;

v is the sliding velocity or tangential contact velocity between a MRF abrasive media and the surface being polished;

R_∞ is a limiting surface roughness, or the lowest surface roughness that can be achieved;

p_a is defined as normal force per unit area acting on the surface being polished;

H is hardness of the surface being polished;

k_T and k_S are wear coefficients;

h is wear depth, and

a is a geometrical constant.

To obtain the wear coefficients k_T and k_S, for the purpose of predicting surface roughness and geometrical change distribution, experiments are carried out on a test strip made of glass.

Estimation of k_T

If the area of the test strip I coupon is A_c and force acting on the test strip as measured by a force sensor is F_c, the granular pressure, p_g may be estimated as:

$$p_g \approx \frac{F_c}{A_c}$$

With a known tangential velocity, v_s, and referring to equation (1), it is possible to estimate k_T from a plot of

$$\ln\left(\frac{R_a - R_\infty}{R_i - R_\infty}\right)$$

versus time. Of course, R_a is the surface roughness of the exposed surface of the test strip or coupon as explained earlier.

Estimation of k_S

Now for large t, equation (2) reduces to:

$$h = \frac{k_s p_g v_s}{H}t$$

from which k_s may be estimated from a plot of h versus time. Of course, h is the wear depth or change in thickness of the test strip or, coupon

Estimation of a

From equations (1) and (2), it follows immediately that:

$$\frac{\partial h}{\partial t} = -a\frac{\partial R_a}{\partial t} + \frac{k_s p_g v_s}{H}$$

Thus, a may be estimated from a plot of

$$\frac{\partial h}{\partial t} \text{ versus } \frac{\partial R_a}{\partial t}$$

provided data for small t are available.

From equation (2), it can be appreciated that material removal, which is based on wear depth, h, is intertwined with surface roughness evolution. Hence, to increase material removal rate (MMR) and also polishing rate, a consideration is to increase, p_a, v or the wear coefficients, k_T and k_S or combinations or permutations of these factors. The following descriptions of various embodiments will teach those skilled in the art how to achieve this.

FIG. **1** is a schematic diagram of a top view of an apparatus **100** for cleaning or polishing an article **200** using a magnetorheological (MR) fluid, and FIG. **2** is a cross-sectional view of the apparatus **100** of FIG. **1** in the direction AA.

In one embodiment, the apparatus **100** includes a carrier **103** that includes a rotatable central shaft **102**, a cylindrical housing **104** coupled to the central shaft **102**, and a ring permanent magnet **106** with two poles (N-pole and S-pole) oriented as shown. The shaft **102** is connected to a driver or spindle (not shown) to spin the shaft **102** and the cylindrical housing **104**.

The carrier **103** includes a cylindrical housing **104** which houses or encases the ring permanent magnet **106**. The cylindrical housing **104** includes a first surface **105** and a second surface **107** with both surfaces opposing each other to define a groove **108**. The housing **104** further houses the ring permanent magnet **106** such that the magnetic field extends through the groove **108**. The groove **108** may be a circumferential channel or side groove **108** between the top and bottom surfaces **105**,**107** arranged to contain a MR fluid **110**. In this embodiment, the MR fluid **110** comprises ferro-magnetic particles of between 1 and 10 microns suspended in water, as carrier fluid. The concentration of the ferro-magnetic particles is 20-40% by volume. The MR fluid **110** also includes minute quantities of abrasive of about 0.3-1% by volume in the form of Silicon Carbide (SiC) to increase material removal rates of a linear glass surface or edge **202** of the glass **200** to be polished by the MRF apparatus **100**. It should be appreciated that other abrasives may be used, for example, Aluminum Oxide, Cerium Oxide or diamonds.

The ring permanent magnet **106** used in this setup is Nd(neodymium)-Fe (ferrite)-B(boron) rare earth permanent magnet to create sufficiently strong magnetic fields to produce an almost instantaneous change of the MR fluid from a liquid state to a semi-solid state throughout the entire side groove **108** and which is still sufficiently pliant to conform to the edge **202** of the article to be polished.

To polish the straight glass edge **202**, the spindle is rotated to spin the central shaft **102** and the carrier **103** about a central axis of the central shaft **102** and from FIG. **1**, the direction of rotation is shown by arrow B. In this way, the groove **108** of the carrier **103** carries the MR fluid **110** continuously to a polishing zone **111** for polishing a portion of the edge **202** of the article. The polishing zone is defined as a section of the carrier **103** where the MR fluid **110** is in contact with or polishes the glass sheet **200**. Since the housing **104** is circular in shape, the polishing zone **111** of FIG. **1** is curved or has an arc-shape. During the rotation, the magnetic field generated by the ring permanent magnet **106** magnetically stiffens the MR fluid **110** particularly at the polishing zone **111** and when the magnetized MR fluid **110** is brought in contact with the glass edge **202**, this enables the MR fluid **110** to grind or polish the edge **202** of the article to remove materials on the edge abrasion. Further, linear reciprocal motion (see arrow C) between the carrier **103** and the edge **202** of the article **200** enables the apparatus **100** to polish the entire length of the edge **202** of the article. The linear reciprocal motion may be accomplished by either moving the shaft **102** (and thus the carrier **103**) linearly along the entire edge **202** of the article whilst maintaining the position of the article **200** or maintaining the position of the shaft **102** and moving the the article **200**.

According to another embodiment of the apparatus, instead of having one movable carrier **103** arranged to house the ring permanent magnet **106**, the apparatus **100** further includes a pair of permanent magnets **112**,**119** arranged to a rotatable central shaft **121** as shown in FIGS. **3***a* and **3***b*. The side groove consists of top and bottom surfaces **105**, **107** opposing each other and a side wall **117** between the top and bottom surfaces **107**,**105** as shown in FIG. **3***b* includes a polishing zone **111**. As the shaft **121** rotates, the pair of permanent magnets **112**,**119** rotate together and with the rotation, the side wall **117** is arranged to carry the MR fluid **110** to the polishing zone **111** so that the MR fluid **110** is able to polish the glass edge **202**. The pair of ring permanent magnets **112**,**119** cooperate to magnetically stiffen the MR fluid **110**. With the combination of the pair of ring permanent magnets **112**,**119**, this increases intensity of the magnetic field generated by the MRF apparatus **100**, leading to quicker polishing of the glass edge **202**. It should be appreciated that the shaft **121** may be connected to a driver (not shown) to move the shaft **121** (and thus, the side wall **117** and the pair of magnets **112**,**119**) to grind the entire edge **202** of the article **200**.

FIG. **4***a* illustrates magnetic flux distribution generated by a single ring magnet based on FEM analysis and FIG. **4***b* illustrates magnetic flux distribution by a pair of ring magnets based on FEM analysis and it should be appreciated that the magnetic flux density generated by the pair of ring magnets **112**,**119** is greater.

With the increase magnetic flux density, this thus increases "media pressure" which is the pressure acting on the MR fluid **110** and the normal stress is increased. In other words, p_a, the normal force per unit area is increased. Consequently, the material removal rate is increased.

FIG. **5**(*b*)(*i*) is a magnified photograph of a surface to be polished with the corresponding surface roughness profile of Ra: 0.51 μm illustrated in FIG. **5**(*a*)(*i*). FIG. **5***b*(*ii*) is a magnified photograph of a part of the surface of FIG. **5***b*(*i*) after being polished by the MRF apparatus **100** having one ring magnet (similar to FIG. **1**) after six passes and the corresponding surface roughness profile of the polished surface (the Ra has been reduced to 0.11 μm) is shown in FIG. **5**(*a*)(*ii*). FIG. **5***b*(*iii*) is a magnified photograph of another part of the surface of FIG. **5***b*(*i*) after being polished by the MRF apparatus **100** configured with a pair of magnets similar to that in FIG. **3** after six passes with the roughness profile shown in FIG. **5**(*a*)(*iii*)(Ra: 0.07 μm). It should be appreciated that the surface after being polished by the pair of magnets is now much smoother compared to one magnet for the same number of passes. In other words, if the same level of smoothness is desired, the MRF apparatus with the pair of magnets would remove materials at a much faster rate than the one with one magnet.

In a second embodiment, the MRF apparatus **100** of FIGS. **1** and **201** of FIG. **3***a* is adapted to increase the tangential contact velocity, v. It has been found that:

$$v=\omega \cdot R=2\pi\theta \cdot R \tag{3}$$

where

- R is radius of the movable carrier as defined by distance from the centre of the shaft to the edge **202** of the article **200** to be polished (i.e. where the MR fluid polishes the glass edge);
- ω is antigonous speed; and
- θ is revolution of the MRF apparatus **100**, specifically the movable carrier.

It can be appreciated that the tangential contact velocity, v, may be increased by either increasing the speed of rotation and/or the radius R of the cylindrical housing.

FIG. **6** is a graph illustrating variations of surface roughness due to different R values of the radius of the carrier, while maintaining the speed of rotation constant at 2000 min^{-1}. It can be appreciated that with a lager radius or size (R=41 mm), a much faster material removal rate is achieved compared to

one with a smaller radius (R=12 mm) since the length of the polishing zone would be increased.

In yet another embodiment, the apparatus **100** of FIG. **1** is adapted to increase contact length between the MR fluid **110** and the glass edge **202** to increase the material removal rate.

FIG. **7** is a top view of an apparatus **300** having a plurality of movable carriers **302** arranged in an end-to-end relationship with each other and to simultaneously polish different parts of an edge **402** of an article **400** such as a sheet of glass. Each of the carriers **302** may be structurally similar to the carrier **103** described above, and includes at least one permanent magnet (not shown) arranged to magnetically stiffen to MR fluid **304** carried by the carrier **302** at a respective curved polishing zone **306**.

FIG. **8** is an enlarged view of a portion of FIG. **7** which shows three of the carriers **302***a*,**302***b*,**302***c* and each carrier includes opposing surfaces **301** (only one of the opposing surface is shown in FIG. **8**) and groove **303** between the opposing surfaces for carrying MR fluid. The grooves **303** have respective polishing zones **306** to polish different parts of the edge **402** of the article **400** simultaneously. To polish the entire length of the edge **402** of the article **400**, the plurality of carriers **302** and the article **402** are moved relative to one another, and it should be appreciated that only a short traverse length or reciprocating distance needs to be travelled between each movable carrier **302** and the glass sheet **400**. The traverse length is shown in FIG. **8** using arrows C which can be a distance between centers of two immediately adjacent carriers **302**. In other words, operating a plurality of such carriers **302** effectively increases the contact length between the MR fluid **304** and the edge **402** since multiple polishing zones **306** are created at the same time. In this way, the contact length is increased and the material from the entire length of the edge **402** may be removed at a much faster rate.

It should be appreciated that the leftmost carrier **302***a* of FIG. **8** is arranged to rotate in a same direction as the rightmost carrier **302***c* (i.e. as shown by arrow D) whereas the centre carrier **302***b* between these two carriers **302***a*,**302***c* is configured to rotate in an opposite direction as shown by arrow E. In other words, every alternate carrier **302***a*,**302***c* rotates in the same direction but two carriers **302***a*,**302***b* (or **302***b*,**302***c*) immediately adjacent to each other rotate in opposite directions.

FIG. **9** shows the leftmost carrier **302***a* and the centre carrier **302***b* of FIG. **8** and FIG. **10** is a magnified view of region F of FIG. **9**. The magnified view of FIG. **10** illustrates ferro-magnetic particles **304***a* of the MR fluid **304** and at regions G, the ferro-magnetic particles of the respective carriers **302***a*,**302***b* just completed polishing of the glass sheet **400** at the respective polishing zones **306** and thus, their alignment are deformed or the particles **304***a* are misaligned. As the leftmost carrier **302***a* rotates in direction D and the centre carrier **302***b* rotates in direction E, this carries the particles to regions H and the close proximity between the two carriers **302***a*,**302***b* allows the particles from respective carriers to be magnetically attracted to each other and thus, the particles are aligned along the magnetic flux again for the next polishing and the shape of the MR fluid **304** is restored continuously. In should be appreciated that this is achieved by the magnets of the adjacent carriers **302***a*,**302***b* being aligned in opposite polarities which generates a magnetic flux bridge between the adjacent magnets which aligns the particles when they are within the bridge.

FIG. **11** illustrates one embodiment which is suited to improve the polishing efficiency by providing an elongate polishing zone. FIG. **11** shows a shematic top view of an apparatus **500** having a rectangular carrier **502** (or one having a rectangular cross-section) having a first surface **501** and a second opposing surface **503** (see FIG. **12**) defining an elongate channel or groove **504** for carrying MR fluid **506**, and FIG. **12** is a cross-section view of FIG. **11** in the direction CC. The elongate channel **504** thus creates an elongate polishing zone **508** for polishing an edge **552** of an article **550** such as a glass panel. The elongate polishing zone **508** is able to polish a longer length of a surface to be polished than the curved polishing zone of the earlier embodiments. The carrier **502** includes a permanent magnet **510** located adjacent the groove for magnetizing the MR fluid **506** along the elongate polishing zone **508**. The apparatus **500** further includes a driver (not shown) for reciprocating the position of the carrier **502** with respect to the article **550** (and it should be appreciated that relative motion may be achieved the other way round too i.e. moving the article **550** instead of the carrier **502**). In other words, relative motion between the carrier **502** and the article is achieved by sliding the movable carrier **502** linearly as shown by arrow J. In this case, contact velocity, v may be increased by oscillating in J direction at higher frequencies, say by connecting the device to any such suitable means, such a pneumatic linear oscillator or a reciprocating cylinder. To see this, we note that, for a sinusoidal oscillation of frequency, f, the contact velocity is given by:

$$v=2d_0\pi f\cdot\cos(2\pi ft) \tag{4}$$

where,

v is contact velocity;

f is oscillation or reciprocating frequency of the movable carrier;

d_o is displacement amplitude of the movable carrier; and

t is variable time.

In other words, increasing the oscillation frequency, f, increases the contact velocity, v, and thus, the material removal rate. It should be appreciated that increasing the contact velocity, v, may also be applicable for the embodiments of FIGS. **3** and **8**, and indeed, other embodiments in this application.

It has been found that reciprocating displacement of the carrier **502**, d, is related to the displacement amplitude based on the following equation:

$$d=d_0\cdot\sin(2\pi ft) \tag{5}$$

Displacement amplitude is defined as a maximum distance that the movable carrier moves from a starting (or zero) position about which the carrier reciprocates or oscillates. As it can be appreciated from Equation (5), to reduce the polishing time, a longer permanent magnet may be used for the movable carrier **502** which results in a greater contact length since a greater polishing zone is created.

Another embodiment of the apparatus employs a plurality of the rectangular carrier **502** and this is shown in FIG. **13**. Each carrier **502** is arranged in an end-to-end and spaced apart relationship, and coupled to each other via a movable connection member **512** so that the movable carriers **502** are arranged linearly in a belt arrangement. In this way, the grooves **504** of the movable carriers **502** are arranged to carry MR fluid **506** to corresponding elongate polishing zones **514** for polishing different parts of an edge **572** of an article **570** at the same time. The relative movement between the carriers **502** and the article is accomplished by reciprocating the connection member **512** as shown by arrow K as the magnetized MR fluid **506** polishes the edge **572** while maintaining the position of the article **570**. It should be apparent that the same effect may be achieved by doing the opposite, just like the other embodiments, which is to move the position of the article **570** while maintaining the position of the carriers **502**.

With the plurality of carriers **502** polishing the edge **572** simultaneously at the respective polishing zones **514**, the polishing time may be drastically reduced to obtain a required finish. Further, the reciprocating frequency, f, of the carriers may be selected to further increase the material removal rate as suggested earlier.

FIG. **14***a* shows a top view of an apparatus **600** according to yet another embodiment of the apparatus. The apparatus **600** includes carrier **601** having opposing surfaces (not shown) which define a groove suitable for receiving the edge **652** of the article **650** to be polished. The carrier **606** is in the form of an endless conveyor for carrying MR fluid **614** and the conveyor **606** is driven by a driver that may be a gear arrangement comprising first and second gears **602**,**604** spaced apart from each other. The carrier **606** includes an inner channel **608** for storing a plurality of permanent magnets **610** arranged equidistantly throughout the conveyor **606**. The plurality of permanent magnets **610** are arranged to stiffen the MR fluid **614** magnetically at their corresponding positions and indeed, throughout the entire length of the conveyor **606**. The distance between the first and second gears **602**,**604** creates an elongate polishing zone **616** for polishing a linear portion of an edge **652** of an article **650**. As the first and second gears **602**,**604** rotate in a same direction, this drives the conveyor **606** in an endless loop carrying the MR fluid **614** to the elongate polishing zone **616** to polish the edge **652** and then away from the elongate polishing zone **616**. The continuous movement of the conveyor **606** thus allows the MR fluid **614** to polish the edge **652** continuously and over a large distance or area.

It should be apparent that the elongate polishing zone **616** may be adjusted depending on the configuration of the endless conveyor **606** so that the elongate polishing zone **616** covers the entire length of the edge **652** to be polished. FIG. **14***b* shows an example of the apparatus **600** adapted with a longer polishing zone **670** compared with that of FIG. **14***a*. This is achieved by lengthening the distance between the two gears **602**,**604** of the gear arrangement (or adding more gears to the gear arrangement). Thus, it can be appreciated that the apparatus **600** may be adapted to cover the entire length of the glass edge.

Optionally, the apparatus **600** further includes a moisturizing device **680** for maintaining moisture content of the MR fluid **614** during the polishing process, and this is illustrated in FIG. **15**. The moisturizing device **680** can include at least one nozzle **682** arranged for spraying atomized water mist **684** onto the MR fluid **614** when the MR fluid **614** is rotated by the conveyor carrier **606** out of the polishing zone **670**. In this way, the MR fluid **614** is kept in a suitable state to be magnetized for polishing the article **650**.

As it can be appreciated from the above, increasing the contact length may reduce the polishing time and to increase the material removal rate, the contact velocity, v, may be increased by increasing rate of rotation, w, of the conveyor **606**, and/or radius, R, of the first and/or second gears **602**,**604**.

The described embodiments enhance or accelerate MRF material removal rate and reduce the MRF time of profiling or polishing edges or surfaces of materials such as sheets or panels of glass or a non-magnetic material. This may be used to finish profiled glass edges to achieve super-polishing quality surfaces, and finishing of brittle materials to removal of sub-surface damage. In particular, the embodiments are particularly useful for polishing generally straight edges or sides of articles. Specifically, the polishing zones of the described embodiments are substantially where the MR fluid in the groove would interface with the part of the article received in the groove.

Since the magnetized MR fluid conforms to the surface or edge to be cleaned or polished, over time, the MR fluid may retain the profile of an edge or surface on which the MR fluid is polishing. This effect is illustrated in FIG. **16** which illustrates a schematic side view of an apparatus **700** having a carrier **702** mounted to a driver **704** for rotating the carrier **702**. The carrier **702** includes a housing **706** carrying a permanent magnet **708** and providing opposing surfaces defining a groove in the form of a channel **710** for carrying MR fluid **712**. Similar to the above embodiments, the driver **704** spins the carrier **702** and the magnetized MR fluid **712** is used to polish a glass edge **714**. Over time, the magnetized MR fluid **712** may retain the edge profile **716** of the glass edge **714** and this may diminish the effectiveness of the MR fluid **712** since there is less pressure acting on the glass edge **714**. In the embodiment of FIG. **8**, the arrangement of the carriers **302** restores the structure of the MR fluid **304** automatically, but for other applications, it may be necessary to use a restoring tool **800** to constrict an un-restored portion (i.e. the edge profile **716**) and bring it back to its original shape. FIG. **17***a* shows the apparatus of FIG. **16** being used with the restoring tool **800** and FIG. **17***b* shows the arrangement of FIG. **17***a* in the direction L. In this example, the restoring tool **800** is made of rigid, rust and impact resistant material such as stainless steel, titanium or metal ceramic composites. The restoring tool **800** has a U-shape constrictor **802** and is held stationary in relation to the rotation of the carrier **702** As the magnetized MR fluid **712** passes through the U-shaped constrictor **802** constricts the magnetized MR fluid **712** to conform the shape of the magnetized MR fluid **712** to the shape of the constrictor's inner surface.

Alternatively described, the apparatus **100**, **500**, **300**, **600** is configured for polishing an to edge **202**, **402**, **552**, **652** of an article **200**, **400**, **550**, **570**, **650** using a magnetorheological (MR) fluid **110** in which the apparatus includes at least one carrier **103** including first and second opposing surfaces **105**, **501**, **107**, **503** defining a groove **108**, **504**. While particularly suitable for addressing the unmet need for efficient method and apparatus for polishing glass edges, it would be apparent that the proposed apparatus and method are not limited to the polishing of glass articles. The first and second opposing surfaces are spaced apart along a first direction **109** to receive the edge. It should be appreciated that the edge can be a side surface or a minor surface of the article, where the width of the edge is narrower than the spacing between the first and second opposing surfaces.

The apparatus includes a magnetic field generator **106** configured to provide a magnetic field in the groove, wherein in operation the MR fluid is disposed in the groove and stiffens in response to the magnetic field to provide at least one polishing zone **111**. As can be understood from the figures, the polishing zone is where the MR fluid interfaces with the article, which would include the edge to be polished. The shape and size of the polishing zone depends therefore on the shape of the groove and the article, and can substantially be found in the groove. The groove may be characterised by an axis of rotational symmetry parallel to the first direction, or it may extend substantially parallel to the second direction.

The apparatus as described above may include one or, more than one of the carriers, such as shown in FIG. **8**, where a plurality of the carriers are aligned substantially parallel to the second direction to simultaneously provide at least one polishing zone to the article. As illustrated, each one of the at least one carrier is rotatable about an axis parallel to the first direction. Immediately adjacent ones of the carriers may be rotatable in different directions. The carrier may take the form of a conveyor, such as an endless conveyor shown in FIG. **14***b*,

in which the conveyor provides the first and second opposing surfaces defining the groove, and the conveyor is operable by the driver. Advantageously, a continuous groove with an elongate polishing zone can be provided. Optionally, a moisturizing device can thus easily be provided to reconstitute or to moisturize the MR fluid.

The apparatus **100** includes a driver configured to provide relative motion between the at least one carrier and the edge of the article in a second direction substantially transverse to the first direction for polishing the edge of the article in the at least one polishing zone. The relative motion can be contributed by the driver providing a rotational motion B of the carrier about an axis in the first direction **109** that contributes to a tangential velocity at the groove relative to article. Alternatively, the relative motion can be contributed by the driver providing a translational relative motion C between the carrier **103** and the article **200** in a direction substantially transverse to the first direction **109**. Yet alternatively, the relative motion may be a combination of both a rotational motion and a translation motion provided by the driver. The relative motion may further be a reciprocating motion, that is, alternating between two opposite directions substantially transverse to the first direction **109**.

The magnetic field generator may be one magnet as shown in FIG. **1**. Alternatively, as shown in FIG. **3***b*, the magnetic field generator may be a set of first and second permanent magnets that provide the first and second opposing surfaces respectively. The magnetic field generator may also be a plurality of magnets arranged along the groove, as in the embodiment of FIG. **13** or FIG. **14**. The magnetic field generator is configured to provide the magnetic field throughout the groove such that in operation the MR fluid is stiffened throughout the groove. Advantageously, the groove is configured to retain substantially all of the MR fluid disposed therein such that it is not necessary to provide a sub-system for delivering the MR fluid to the carrier and for collecting the MR fluid from the carrier during operation. This hugely simplifies the apparatus as well as enabling easy scaling-up of the apparatus to enable a longer length of the edge to be polished simultaneously. As the MR fluid is substantially retained on the carrier throughout the polishing operation, a restoring tool may be provided to shape the MR fluid so that as the MR fluid is brought into the polishing zone, there is a desired amount of interface between the MR fluid and the edge to be polished.

Also disclosed is a method for polishing an edge of an article, the method involving providing at least one carrier including first and second opposing surfaces defining a groove, the first and second opposing surfaces being spaced apart in a first direction to receive the edge; and a magnetic field generator configured to provide a magnetic field in the groove to stiffen MR fluid disposed in the groove to provide at least one polishing zone; receiving the edge in the polishing zone; and driving relative motion between the at least one carrier and the edge in a second direction substantially transverse to the first direction. The method may further include stiffening the MR fluid throughout the groove. The method may also include retaining substantially all of the MR fluid disposed in the groove. The method may inviolve simultaneously receiving different parts of the edge in the groove. The method may further include rotating immediately adjacent ones of the carriers in different directions.

The described embodiments should not be construed as limitative. For example, instead of water as the carrier fluid, other types of carrier fluids such as oil may be used. Further, other suitable magnets may be employed, not just the Nd—Fe—B permanent magnet. Indeed, any type of permanent magnets such as rare earth permanent magnets and above may be used to produce relatively strong magnetic fields to produce sufficient stiffness in the MR fluid **110** for rapid removal of materials. Although certain features are explained in relation to one embodiment, it should be appreciated that those features may also be applicable to the other embodiments.

Having now fully described various embodiments of the proposed method and apparatus, it should be apparent to one of ordinary skill in the art that many modifications can be made hereto without departing from the scope as claimed.

What is claimed is:

1. An apparatus for polishing an edge of an article using a magnetorheological (MR) fluid, the apparatus comprising:

at least one carrier including:

first and second opposing surfaces defining a groove, the first and second opposing surfaces being spaced apart along a first direction to receive the edge; and

a magnetic field generator configured to provide a magnetic field in the groove, wherein in operation the MR fluid is disposed in the groove and stiffens in response to the magnetic field to provide at least one polishing zone; and

a driver configured to provide a relative motion between the at least one carrier and the edge of the article in a second direction substantially transverse to the first direction for polishing the edge of the article in the at least one polishing zone, wherein the relative motion further comprises a reciprocating motion.

2. The apparatus according to claim **1**, wherein the magnetic field generator further comprises first and second permanent magnets providing the first and second opposing surfaces respectively.

3. The apparatus according to claim **1**, wherein the magnetic field generator is configured to provide the magnetic field throughout the groove such that the MR fluid is stiffened throughout the groove.

4. The apparatus according to claim **3**, wherein the groove is configured to retain substantially all of the MR fluid disposed therein.

5. The apparatus according to claim **1**, wherein the groove is annular and wherein the groove is characterized by an axis of rotational symmetry parallel to the first direction.

6. The apparatus according to claim **1**, wherein the groove extends substantially parallel to the second direction.

7. The apparatus according to claim **1**, wherein the relative motion further comprises a rotational motion of the at least one carrier.

8. The apparatus according to claim **1**, wherein a plurality of carriers of the at least one carrier is aligned substantially parallel to the second direction to simultaneously provide at least one polishing zone.

9. The apparatus according to claim **8**, wherein each one of the at least one carrier is rotatable about an axis parallel to the first direction.

10. The apparatus according to claim **9**, wherein immediately adjacent ones of the carriers are rotatable in different directions.

11. The apparatus according to claim **1**, further comprising a restoring tool configured to shape the MR fluid.

12. The apparatus according to claim **1**, wherein the at least one carrier further comprises a conveyor configured to provide the first and second opposing surfaces and wherein the conveyor is operable by the driver.

13. The apparatus according to claim **12**, wherein the magnetic generator further comprises a plurality of magnets arranged equidistantly along the conveyor.

14. The apparatus according to claim 12, further comprising a moisturizing device configured to moisturize the MR fluid.

15. A method for polishing an edge of an article, the method comprising:

providing at least one carrier including:

first and second opposing surfaces defining a groove, the first and second opposing surfaces being spaced apart in a first direction to receive the edge; and

a magnetic field generator configured to provide a magnetic field in the groove to stiffen magnetorheological (MR) fluid disposed in the groove to provide at least one polishing zone;

receiving the edge in the polishing zone; and

driving a relative motion between the at least one carrier and the edge in a second direction substantially transverse to the first direction, wherein the relative motion further comprises a reciprocating motion.

16. The method according to claim 15, further comprising stiffening the MR fluid throughout the groove.

17. The method according to claim 16, further comprising retaining substantially all of the MR fluid disposed in the groove.

18. The method according to claim 15, further comprising simultaneously receiving different parts of the edge in the groove.

19. The method according to claim 18, further comprising rotating immediately adjacent ones of the carriers in different directions.

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